



**ELECTRONIC COPY**

LG637454700  
Report verification at [igi.org](http://igi.org)

**LABORATORY GROWN DIAMOND REPORT**

June 6, 2024  
IGI Report Number **LG637454700**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **10.51 X 7.16 X 4.51 MM**

**GRADING RESULTS**

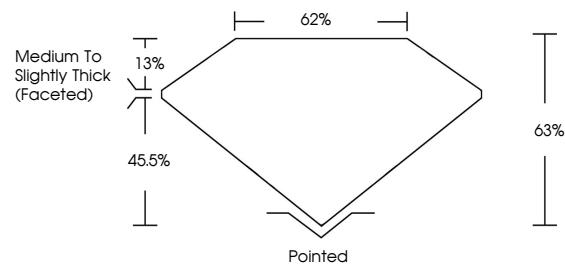
Carat Weight **2.14 CARATS**  
Color Grade **E**  
Clarity Grade **VS 2**

**ADDITIONAL GRADING INFORMATION**

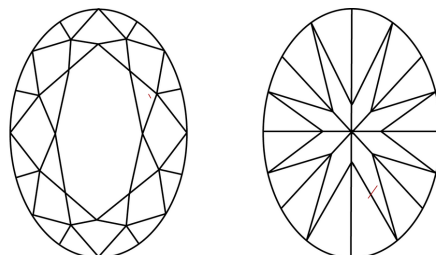
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG637454700**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.



Sample Image Used

**COLOR**

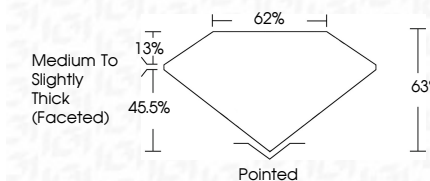
D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**

June 6, 2024  
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OVAL BRILLIANT  
10.51 X 7.16 X 4.51 MM  
Carat Weight 2.14 CARATS  
Color Grade E  
Clarity Grade VS 2  
Depth 63%  
Table 62%  
Girdle Medium to Slightly Thick (Faceted)  
Culet Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) IGI LG637454700  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa